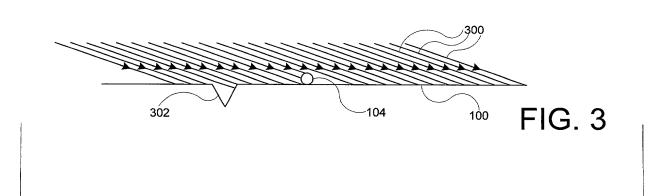


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Inventors: Steve Biellak, Stanley E. Stokowski and Mehdi Vaez-Iravani
Title: Systems And Methods For A Wafer Inspection System Using Multiple Angles And
Multiple Wavelength Illumination
Atty. Docket No. M-10693 US
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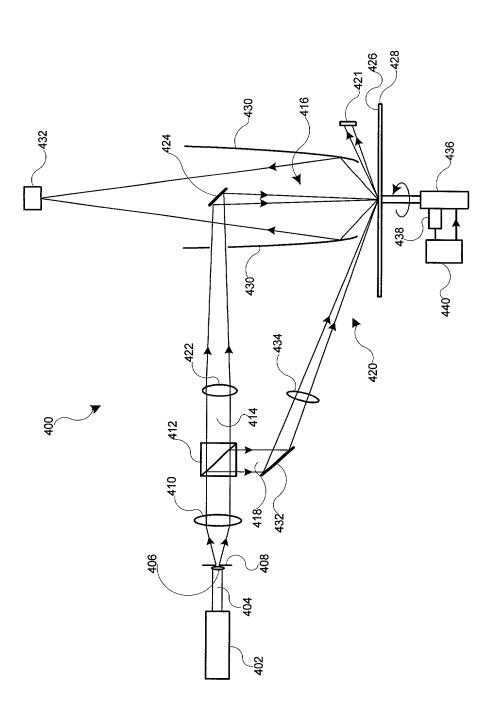


FIG. 4

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